

CNC PROCESSING

		Standard-Quality	Precision-Quality
Dimensions [ISO 10110-1]			
Diameter	mm	8 - 300	4 - 250
Tolerance	mm	± 0.10	± 0.05
Center thickness	mm	2 - 60	2 - 60
Tolerance	mm	± 0.10	± 0.05
Surface form [ISO 10110-1; 12]		geometry dependent up to	
Radius of curvature – local cc	mm	15	
Clear aperture	% of Ø	95	90
Clear aperture surface slope	degree	75	50
Surface form tolerances [ISO 10110-5] and Aspheric surfaces [ISO 10110-12]			
3/A (B, C) RMSi < D; slope < F; slope integration length = G; spatial sampling resolution = H; see also ISO 14999-4			
Tolerance of radius of curvature	%	± 0.10	± 0.05
Sagitta deviation – A (Power)	fringe (μm)	30 - 10 (7.5 - 2.5)	3 (0.75)
Irregularity – B (PV)	fringe (μm)	10 - 4 (2.5 - 1)	1 (0.3)
Rotational invariant irregularity – C	fringe (μm)	4 - 1.5 (1.0 - 0.4)	0.5 (0.14)
RMS irregularity – RMS _i – D	fringe (μm)	3 - 1.2 (0.75 - 0.3)	0.3 (0.09)
Slope tolerance – F / G / H	arc sec/mm/mm	180 / 1 / 0.1	40 / 1 / 0.1
Centration [ISO 10110-6] 4/σ (L)			
Edge thickness variation (defines tilt angle)	μm	25	15
Tilt angle of the aspheric surface to the second surface – σ	arc min	2.50	1
Lateral displacement of the aspheric to the edge of the lens – L	mm	0.02	0.01
Lateral displacement of the aspheric to the second surface – L	mm	0.03	0.02
Surface imperfections [ISO 10110-7; 5/ N x A; L N “x A“]			
Dig – N x A ¹		2 x 0.40	2 x 0.10
Scratches – L N “x A“ ¹		L2 x 0.10	L2 x 0.06
MIL – Scratch / Dig		40 – 20	20 – 10
Surface texture [ISO 10110-8]			
Surface roughness – Rq	nm	3.00	1.50
Measurement			
Full-surface interferometric measurement		optional	

DIAMOND TURNING

Ultra-precise cutting using monocrystalline diamond is the key technology for manufacturing virtually any optical functional surface with the utmost precision. This enables the processing of non-ferrous metals, nickel-phosphorus coatings, plastics, crystals and IR lenses.

Manufacturing dimensions [ISO 10110-1]		
Achievable diameters	mm	1 - 420
Center thickness		from 0.5 ¹
Surface shape [ISO 10110-1; 12] up to		
Irregularity - B (PV) ²	nm	100
RMS irregularity - RMSi - D		20
Surface roughness - Rq		1

1 Depends on diameter and material

2 Often also called the PV - error of the measured surface. Means the total surface deviation corrected for Sagitta error (power).

Available technologies	
= Diamond turning with 2 and 3 linear axes	
= Fly cutting	
= Slow tool servo	
Processable materials	
= Copper, aluminum, brass, nickel silver	
= Nickel-phosphorus layers	
= Polycarbonate, PMMA	
= Silicon, germanium, zinc sulfide	
= IR lenses	
Achievable optical component geometries	
= Aspheres	= Microlenses
= Spheres	= Fresnel structures
= Cylinders	= Diffractive optical elements
= Toroids	= Freeforms

HIGH-END FINISHING

Dimensions [ISO 10110-1]			
Diameter	mm	6 - 300	
Tolerance		± 0.03	
Center thickness		< 60	
Tolerance		± 0.01	
Surface form [ISO 10110-1; 12]		geometry dependent up to	
Radius of curvature – local cc	mm % of Ø	15	
Clear aperture		90	
Clear aperture surface slope		75	
Surface form tolerances (ISO 10110-5) and Aspheric surfaces (ISO 10110-12)			
3/A (B, C) RMSi < D; slope < F; slope integration length = G; spatial sampling resolution = H; see also ISO 14999-4			
Tolerance of radius of curvature	% fringe (µm)	± 0.02	
Sagitta deviation – A (Power)		0.30 (0.08)	
Irregularity – B (PV)		0.30 (0.08)	
Rotational invariant irregularity – C		0.20 (0.05)	
RMS irregularity – RMS _i – D		0.10 (0.03)	
Slope tolerance – F / G / H		12 / 1 / 0.1	
Centration [ISO 10110-6] 4/ σ (L)			
Edge thickness variation (defines tilt angle)	µm arc min	5	
Tilt angle of the aspheric surface to the second surface – σ		0.35	
Lateral displacement of the aspheric to the edge of the lens – L		0.01	
Lateral displacement of the aspheric to the second surface – L		0.01	
Surface imperfections [ISO 10110-7; 5/ N x A; L N “ x A“]			
Dig – N x A ¹		2 x 0.04	
Scratches – L N “ x A“ ¹		L2 x 0.04	
MIL – Scratch / Dig		20 – 10	
Surface texture [ISO 10110-8]			
Surface roughness – Rq	nm	0.50	
Measurement			
Full-surface interferometric measurement		guaranteed	